

Development of an Electrochemical Oxygen Compressor and Generator for Spacesuit Oxygen Resupply

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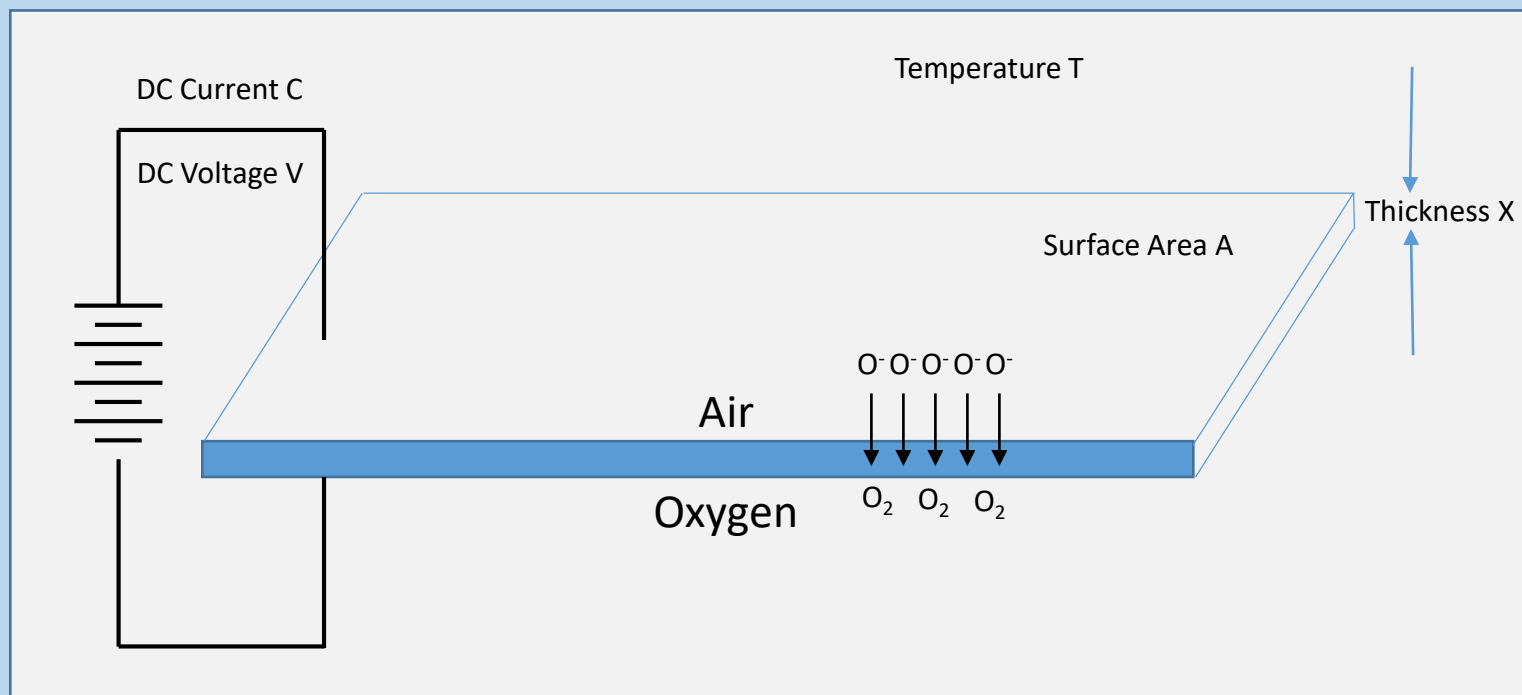
Agenda

- **Oxygen Transport Membrane Fundamentals**
- **Spacesuit Oxygen Tank Recharge Application**
- **eCOG-C Feasibility Assessment**
- **Summary**

Oxygen Transport Membrane Fundamentals

- **Function**: OTM can separate oxygen from other gases, because oxygen ions get electrochemically transported through some oxide materials “infinitely selective”
- **Hot**: Electrical resistance is essentially infinite at room temperature, common process temps are 650-750 C.
- **Thin**: Resistance across OTM is a function of membrane thickness. Thin membranes use less power.
- **Brittle**: The oxide materials that perform the best for OTMs are brittle, especially when they are thin.

Oxygen Transport Membrane Fundamentals



Oxygen Transport Membrane Fundamentals

- One solution to the hot, thin, brittle problem: OTM is embedded in a multi-layer wafer, that supports the OTM structurally, and creates a reservoir for oxygen



Photo of cell stack

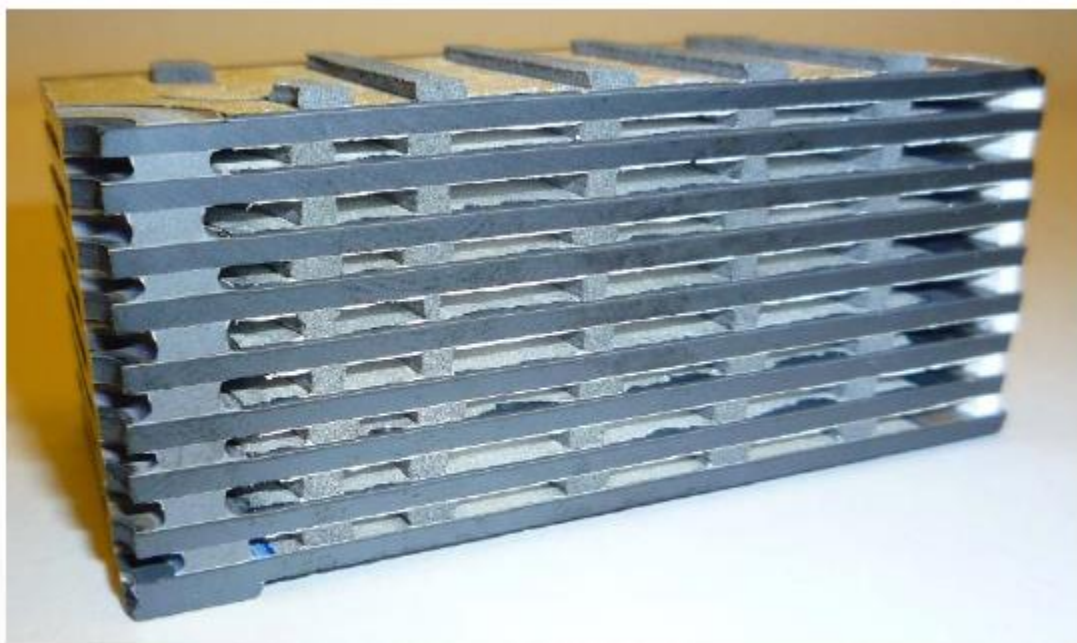
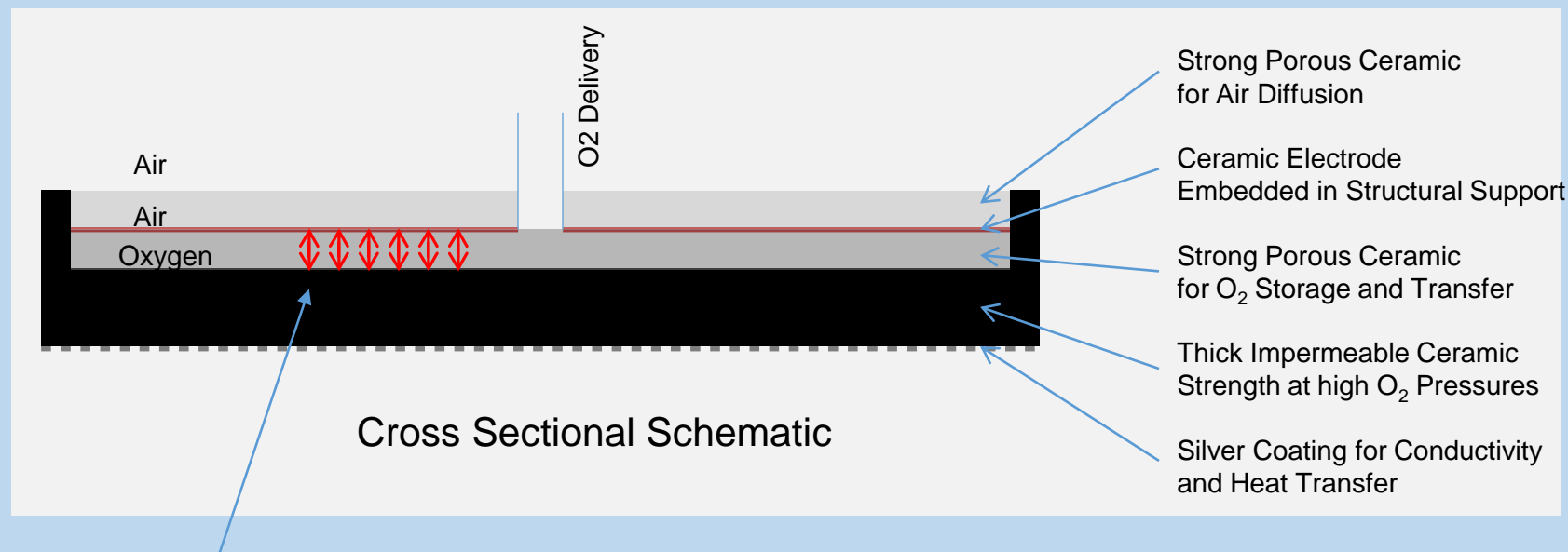


Photo of cutaway

Oxygen Transport Membrane Fundamentals

- The current OTM has an internal reservoir in each wafer. Oxygen puts the wafer in tension. The wafer can hold 300 psi, but not 600 psi.



Oxygen exerts pressure force on the wafer

Spacesuit O₂ Tank Recharge

High Pressure O₂ Gas Tanks

Pressure: No Issues: Pressurization is done prior to launch
Purity: No Issues: Purity can be validated prior to launch, risk of contamination after launch is low
Safety: Favorable: No energy is added to the system during the mission
Summary: Great for missions with few planned EVAs. Concerns about size and weight for exploration

Cryogenic Liquid O₂ (LOX)

Pressure: Pressurization occurs as heat is added to the system
Purity: No Issues: Purity can be validated prior to launch, risk of contamination after launch is low
Safety: Lots of stored energy. Apollo 13 mishap involved LOX
Summary: Best suited for short duration missions with many planned EVAs

Low Pressure Water Electrolysis + Drier + Mechanical Compressor

Pressure: Demonstrated with technology demonstrator systems
Purity: In-flight purity verification will likely be required; contamination risk is credible (compressor)
Safety: Adding energy to O₂ during mission – compressors that keep O₂ cool can be large
Summary: May trade well for exploration missions, especially if reliable purity verification is developed

Low Pressure Water Electrolysis + PSA O₂ Concentrator + Mechanical Compressor

Pressure: Demonstrated with technology demonstrator systems
Purity: In-flight purity verification will likely be required; severe concerns about PSA product purity
Safety: Adding energy to O₂ during mission – compressors that keep O₂ cool can be large
Summary: PSA product purity concerns need to be addressed before this can be evaluated

High Pressure Water Electrolysis + O₂ Drier

Pressure: Demonstrated with technology demonstrator systems (thick end caps)
Purity: Must remove water, verification may be easier if only water needs to be measured
Safety: Fundamental safety issue: stack has hydrogen, high pressure O₂, and ignition source
Summary: Safety issues cannot be designed out of the system

PEM Electrolyte Electrochemical O₂ Compressor

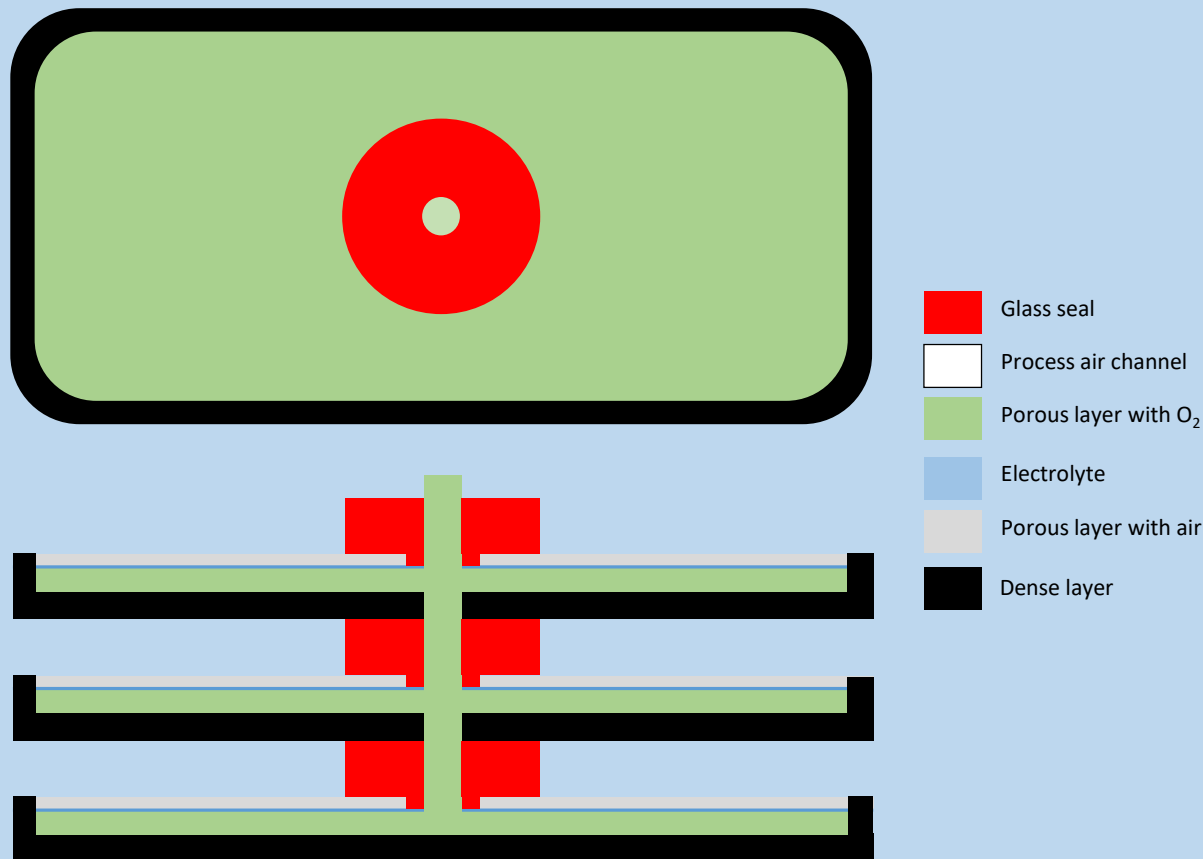
Pressure: 14,000 kPa demonstrated with lab prototype
Purity: Must remove water, verification may be easier if only water needs to be measured
Safety: Fundamental, but less severe: solid fuel (not H₂), high pressure O₂, and ignition source
Summary: Kinetics needs to be demonstrated before this can be evaluated

Electrochemical Oxygen Generator & Compressor (eCOG-C)

Pressure: 14,000 kPa demonstrated with lab prototype
Purity: No in-flight purity verification needed
Safety: Adding energy to O₂ during mission - high temp hazards, but fire triangle ok (no fuel)
Summary: Good potential for human exploration: solid state, high purity, no fuel near O₂

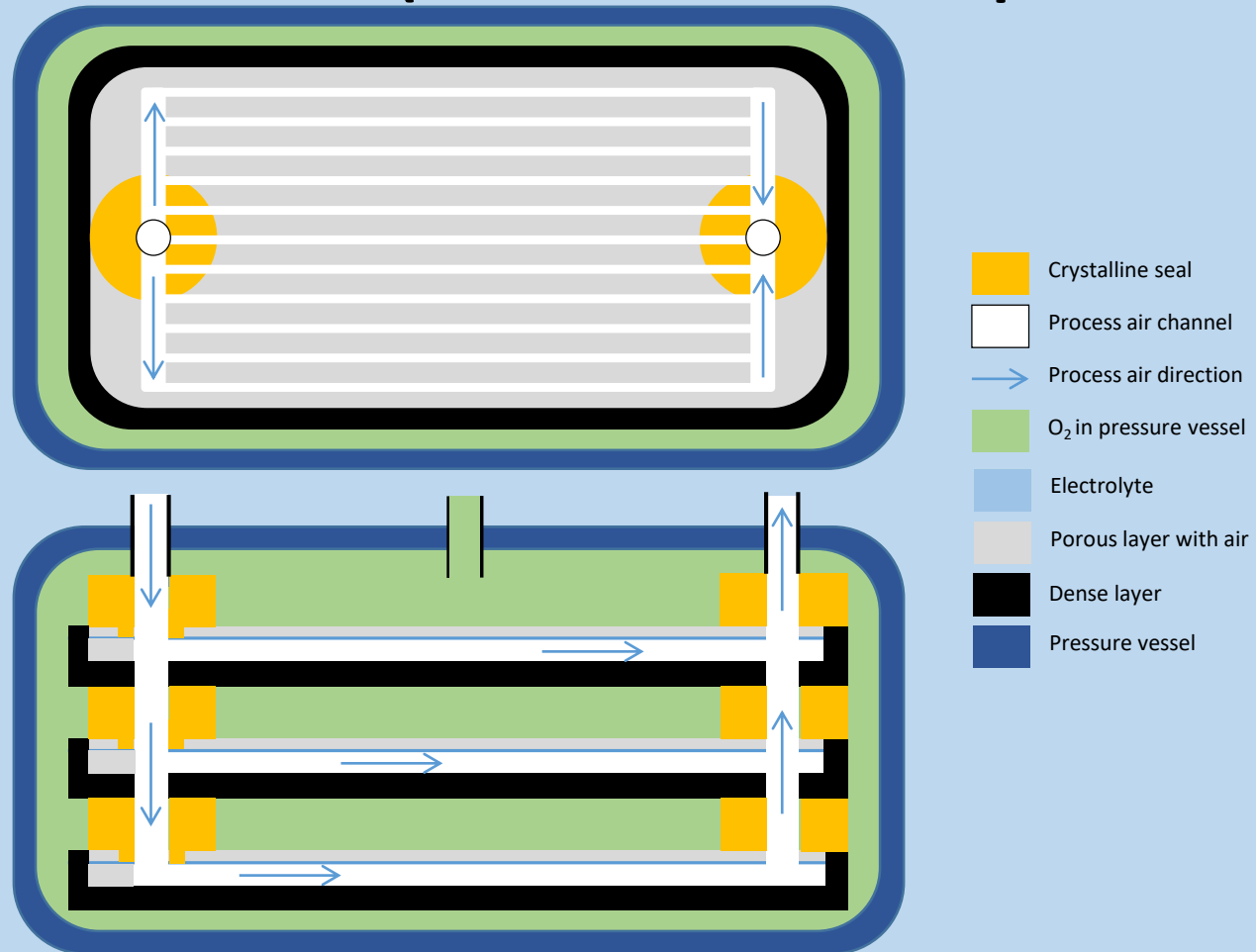
Feasibility Assessment

- The current OTM wafer has an oxygen reservoir internal to the wafer. Glass seals connect the wafers

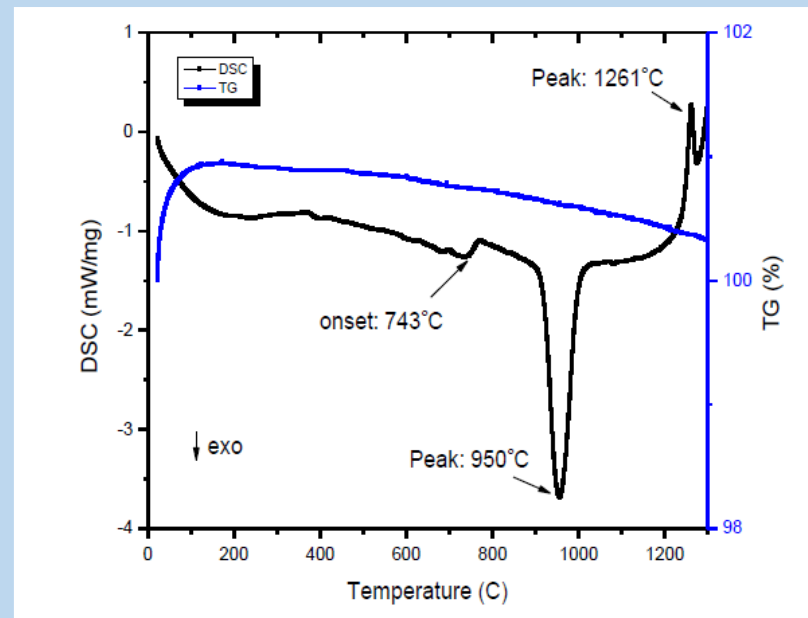
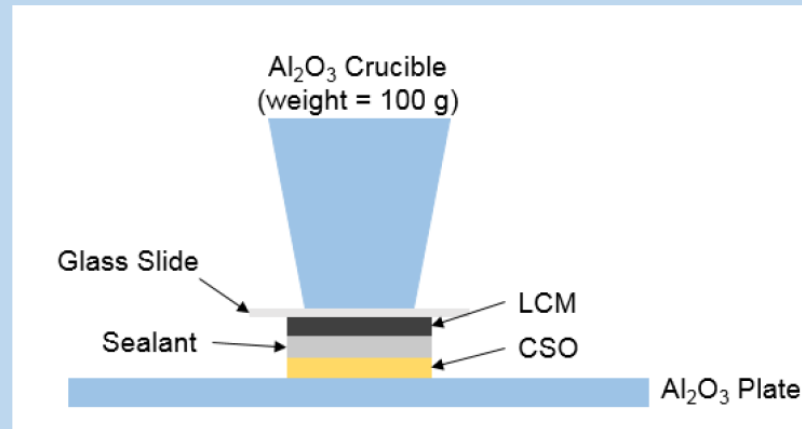


Feasibility Assessment

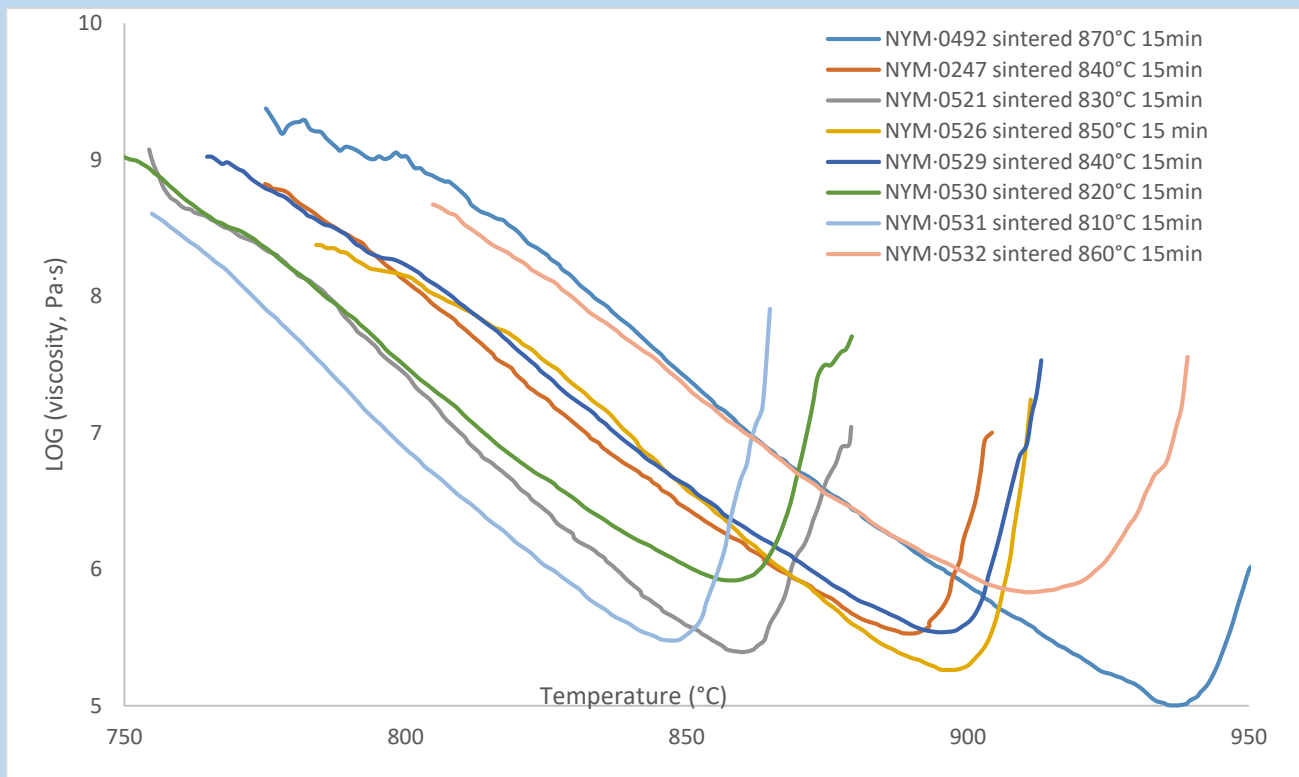
- eCOG-C flows low pressure air internally, oxygen is external to the wafer (contained inside a pressure vessel)



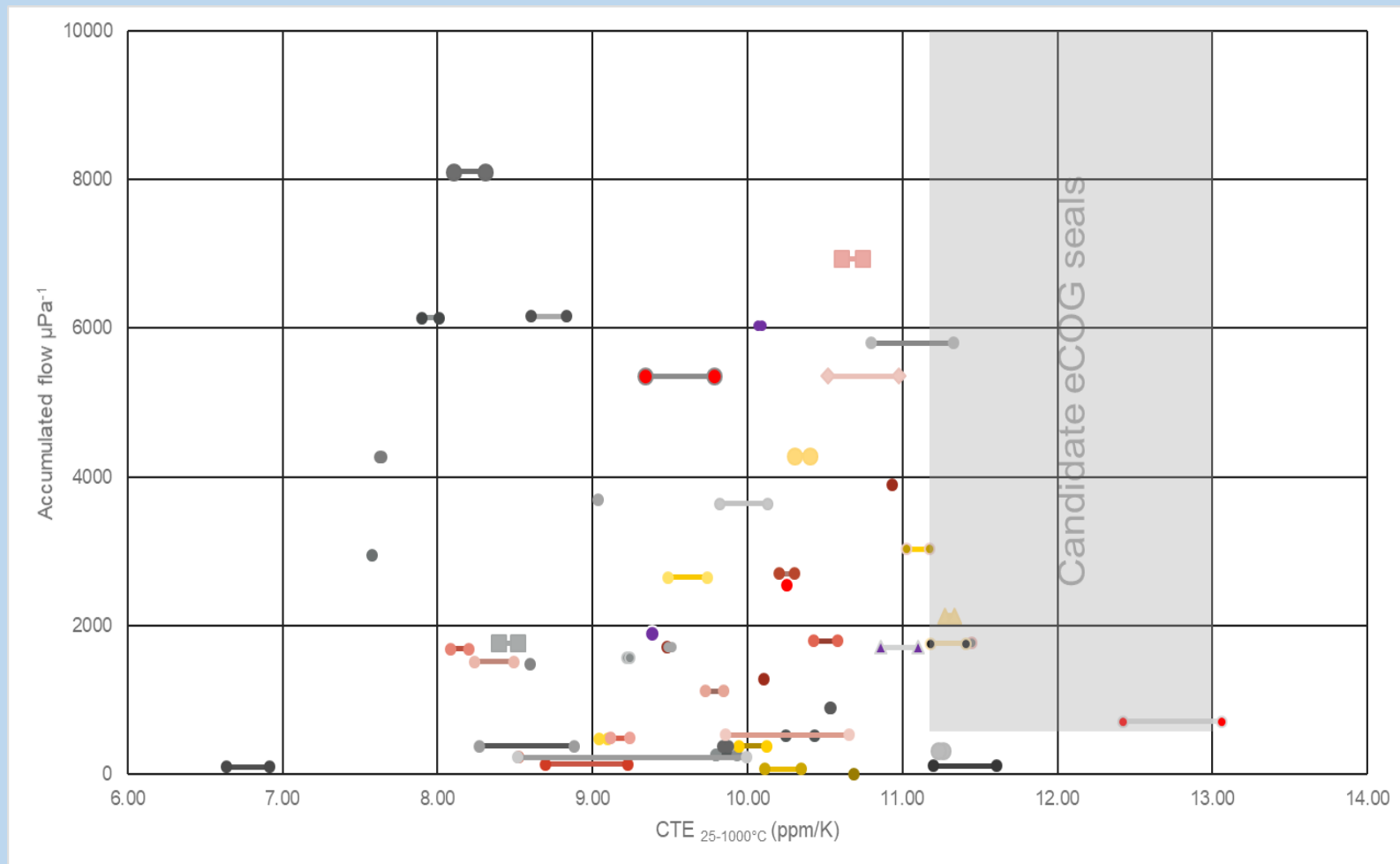
Feasibility Assessment



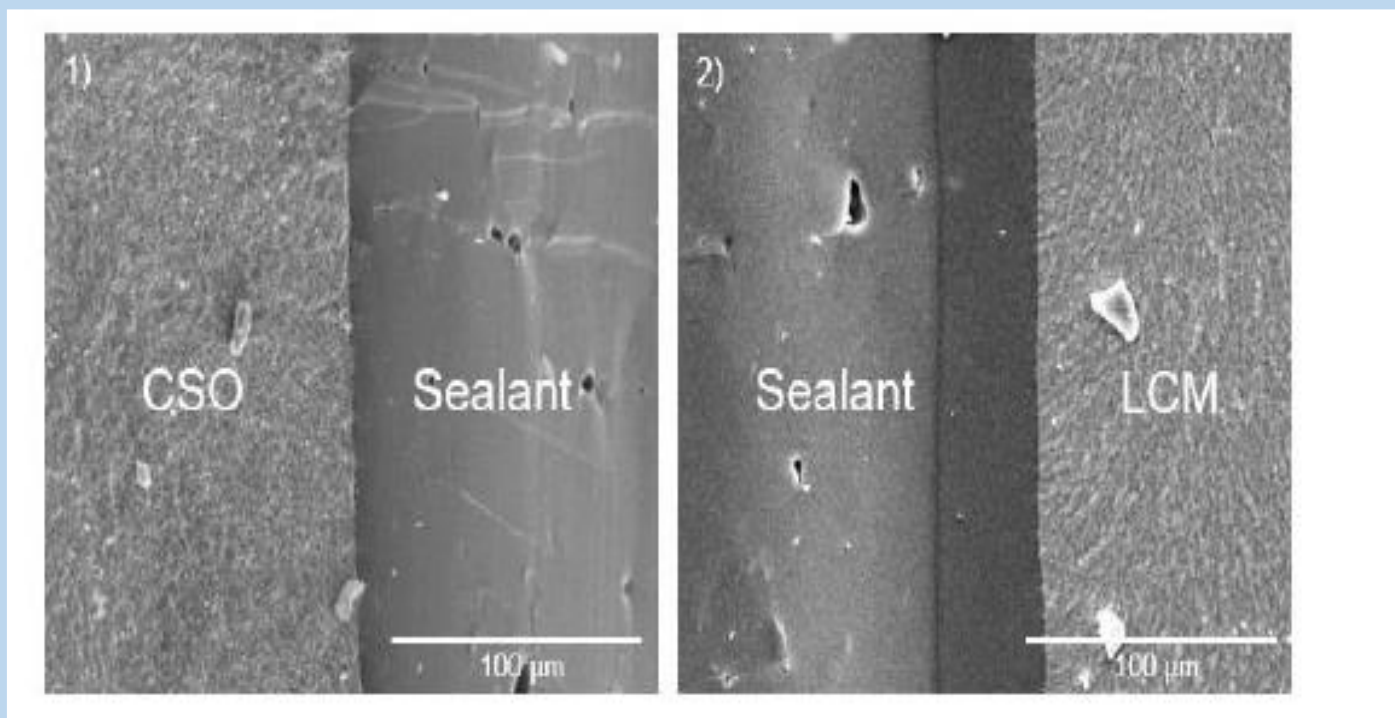
Feasibility Assessment



Feasibility Assessment



Feasibility Assessment



Summary

- **Wafers can be reconfigured to place the oxygen external to the wafer. This puts the wafer in compression and makes >3000psi oxygen delivery possible.**
- **The #1 technical risk is developing a crystalline interconnecting seal that is strong, adheres to the wafers, and has a coefficient of thermal expansion that matches the wafer.**
- **The #2 technical risk is developing a modified wafer that has internal flow channels.**
- **Preliminary assessment of seal and wafer is favorable**

Thank You